IN THE UNITED STATES PATENT AND TRAVEMARK OFFICE

Applicants:

Hsiao, Tommy C.; Hui, Angela T.; Ogle, Robert B.; Pham, Tuan Digy

Plat, Marina V.; Ramsbey, Mark T.; Shen, Lewis

Assignee:

Advanced Micro Devices, Inc.

Title:

Polished Flash Process With Metal Gates And Improved Planarity

Serial No.:

09/430,366

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J. Chen

Spice

Group Art Unit: 2813

Docket No.:

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COMMISSIONER FOR PATENTS

Washington, D.C. 20231

San Jose California
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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(c) WITH FEE

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicant(s) wish to call the following documents (copies enclosed) to the attention of the Examiner for the above-identified patent application. The documents were cited in the for the corresponding Application No.:

A form PTO-1449 listing these documents is enclosed.

The relevance of any non-English language documents cited herein is explained in the accompanying copy of the .

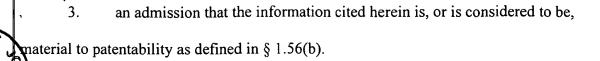
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LAW OFFICES OF SKJERVEN MORRILL MacPHERSON LLP

25 METRO DRIVE SUITE 700 SAN JOSE, CA 95110 (408) 453-9200 FAX (408) 453-7979

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EXPRESS MAIL LABEL NO: Respectfully submitted,

EL 710215827US

Edward C. Kwok

Attorney for Applicants

Reg. No. 33,938

LAW OFFICES OF SKJERVEN MORRILL MacPHERSON LLP

25 METRO DRIVE SUITE 700 SAN JOSE, CA 95110 (408) 453-9200 FAX (408) 453-7979